L Number	Hits	Search Text	DB	Time stamp
1	8685	(surface substrate) with (("not" near porous) non-porous)	USPAT;	2004/04/19 11:47
			US-PGPUB,	
			ЕРО; ЈРО;	
			DERWENT	
2	1026	((surface substrate) with (("not" near porous) non-porous)) and (rough	USPAT;	2004/04/19 11:47
		roughness)	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
3	1064	((surface substrate) with (("not" near porous) non-porous)) and laser	USPAT;	2004/04/19 11:47
			US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	
4	1611	((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5	USPAT;	2004/04/19 11:48
		desor\$5 ioniz\$4)	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
5	67	((surface substrate) with (("not" near porous) non-porous)) and	USPAT;	2004/04/19 11:48
		(((surface substrate) with (("not" near porous) non-porous)) and (rough	US-PGPUB;	
		roughness)) and (((surface substrate) with (("not" near porous)	ЕРО; ЈРО;	
		non-porous)) and laser) and (((surface substrate) with (("not" near	DERWENT	
	:	porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4))		
6	15	(((surface substrate) with (("not" near porous) non-porous)) and	USPAT;	2004/04/19 11:48
		(((surface substrate) with (("not" near porous) non-porous)) and (rough	US-PGPUB;	
		roughness)) and (((surface substrate) with (("not" near porous)	ЕРО; ЈРО;	
		non-porous)) and laser) and (((surface substrate) with (("not" near	DERWENT	
	Í	porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4))) and analyte		
7	1	((((surface substrate) with (("not" near porous) non-porous)) and	USPAT;	2004/04/19 11:49
		(((surface substrate) with (("not" near porous) non-porous)) and (rough	US-PGPUB;	
		roughness)) and (((surface substrate) with (("not" near porous)	ЕРО; ЈРО;	
[non-porous)) and laser) and (((surface substrate) with (("not" near	DERWENT	
		porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4))) and analyte) and		
	_	250/423R,424,425,423P.ccls.	**************************************	2004/04/10 11 64
8	6	(F , ,	USPAT;	2004/04/19 11:54
		250/423R,424,425,423P.ccls.	US-PGPUB;	
			ЕРО; ЈРО;	
		//	DERWENT	2004/04/10 11:54
9	0	((surface substrate) with (("not" near porous) non-porous) and	USPAT; US-PGPUB;	2004/04/19 11:54
		250/423R,424,425,423P.ccls.) and in-situ	EPO; JPO;	
			DERWENT	
	2	4527059.pn.	USPAT;	2004/02/26 15:46
1 -	2	4327033.ptt.	US-PGPUB;	2004/02/20 13.40
			EPO; JPO;	
			DERWENT	
_	2	4988879.pn.	USPAT;	2004/02/26 13:47
			US-PGPUB;	230 11 02 12 13 . 41
			EPO; JPO;	
			DERWENT	
-	2	5326633.pn.	USPAT;	2004/02/26 13:48
	_	***	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	8507	(surface substrate) with (("not" near porous) non-porous)	USPAT;	2004/04/19 11:46
		, , , , , , , , , , , , , , , , , , , ,	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	1004	((surface substrate) with (("not" near porous) non-porous)) and (rough	USPAT;	2004/04/19 11:47
		roughness)	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	

				C.
-	1560	((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)	USPAT; US-PGPUB;	2004/04/19 11:47
			ЕРО; ЈРО;	
			DERWENT	
-	1009	((surface substrate) with (("not" near porous) non-porous)) and laser	USPAT;	2004/04/19 11:47
		•	US-PGPUB; EPO; JPO;	
			DERWENT	
-	65	(((surface substrate) with (("not" near porous) non-porous)) and (rough	USPAT;	2004/02/26 16:30
		roughness)) and (((surface substrate) with (("not" near porous)	US-PGPUB;	
		non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate)	ЕРО; ЈРО;	
	,,,	with (("not" near porous) non-porous)) and laser)	DERWENT	2004/04/10 11 40
-	15	((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)	USPAT; US-PGPUB;	2004/04/19 11:48
		non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate)	EPO; JPO;	
		with (("not" near porous) non-porous)) and laser)) and analyte	DERWENT	
-	2	6399177.pn.	USPAT;	2004/02/26 16:14
		-	US-PGPUB;	
		•	ЕРО; ЛРО;	
		C	DERWENT	2004/02/26 16:10
-	1	Sunner-Jan\$.in.	USPAT; US-PGPUB;	2004/02/26 16:19
	1		ЕРО; ЛРО;	
			DERWENT	
-	1	Alimpiev-Sergey\$.in.	USPAT;	2004/02/26 16:20
			US-PGPUB;	
			EPO; JPO; DERWENT	
_	1	Nikiforovl-Sergey\$.in.	USPAT;	2004/02/26 16:20
			US-PGPUB;	200 11 02 12 10 12 1
			ЕРО; ЛРО;	
			DERWENT	0004100405
-	2	((((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)	USPAT; US-PGPUB;	2004/02/27 11:25
		non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and ((surface substrate)	ЕРО; ЛРО;	
		with (("not" near porous) non-porous)) and laser)) and	DERWENT	
		(250/423R,424,425,423P.ccls.)		
-	9	((((surface substrate) with (("not" near porous) non-porous)) and (rough	USPAT;	2004/02/26 16:25
		roughness)) and (((surface substrate) with (("not" near porous) non-porous)) and (adsor\$5 desor\$5 ioniz\$4)) and (((surface substrate)	US-PGPUB; EPO; JPO;	
		with (("not" near porous) non-porous)) and laser)) and (laser with	DERWENT	
		puls\$3)		
-	2	(((surface substrate) with (("not" near porous) non-porous)) and	USPAT;	2004/02/26 16:30
		(((surface substrate) with (("not" near porous) non-porous)) and (rough roughness)) and (((surface substrate) with (("not" near porous)	US-PGPUB;	
		non-porous)) and (((surface substrate) with (("not" near porous) non-porous)) and laser)) and (250/423R,424,425,423P.ccls.)	EPO; JPO; DERWENT	
_	187	(surface near rough\$4) same (non-porous ("not" adj porous))	USPAT;	2004/02/26 17:23
			US-PGPUB;	
			ЕРО; ЛРО;	
	30	((1))	DERWENT	2004/02/26 12 21
-	30	((surface near rough\$4) same (non-porous ("not" adj porous))) and laser	USPAT; US-PGPUB;	2004/02/26 19:01
			EPO; JPO;	
			DERWENT	
-	2	(((surface near rough\$4) same (non-porous ("not" adj porous))) and	USPAT;	2004/02/26 17:24
		laser) and analyte	US-PGPUB;	
			EPO; JPO; DERWENT	
_	45	((surface near rough\$4) same (non-porous ("not" adj porous))) and	USPAT;	2004/02/26 18:57
		(nanometer nm)	US-PGPUB;	
			ЕРО; ЈРО;	
	L		DERWENT	

-	12	(((surface near rough\$4) same (non-porous ("not" adj porous))) and laser) and (nanometer nm)	USPAT; US-PGPUB;	2004/02/26 17:44
			ЕРО; ЈРО;	
	120	(II All 1') '41 (1 1)	DERWENT	2004/02/26 19:56
-	138	(non-porous ("not" adj porous)) with (rough roughness)	USPAT; US-PGPUB;	2004/02/26 18:56
			EPO; JPO;	
			DERWENT	
-	27	((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/27 09:59
		desor\$5 ioniz\$4)	US-PGPUB;	
			ЕРО; ЈРО;	
			DERWENT	
-	16	(((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 19:01
•		desor\$5 ioniz\$4)) and (nanometer nm)	US-PGPUB; EPO; JPO;	
			DERWENT	
-	1	(((((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 18:59
		desor\$5 ioniz\$4)) and (nanometer nm)) and (mass adj spectromet\$2)	US-PGPUB;	
			ЕРО; ЈРО;	
	_		DERWENT	
-	2	(((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5	USPAT;	2004/02/26 18:59
		desor\$5 ioniz\$4)) and (mass adj spectromet\$2)	US-PGPUB; EPO; JPO;	
			DERWENT	
- .	2	((non-porous ("not" adj porous)) with (rough roughness)) and (mass adj	USPAT;	2004/02/26 18:59
		spectromet\$2)	US-PGPUB;	
			ЕРО; ЛРО;	
			DERWENT	2004/02/26 10 02
-	6	((((non-porous ("not" adj porous)) with (rough roughness)) and (adsor\$5 desor\$5 ioniz\$4)) and (nanometer nm)) and laser	USPAT; US-PGPUB;	2004/02/26 19:03
		desorationization and (nanometer min) and laser	ЕРО; ЛРО;	
			DERWENT	
-	1943	laser same analyte	USPAT;	2004/02/27 09:59
			US-PGPUB;	
			ЕРО; ЛРО;	
	34	(laser same analyte) and ((surface substrate) with (("not" near porous)	DERWENT USPAT;	2004/02/27 11:28
_	34	non-porous))	US-PGPUB;	2004/02/27 11.28
			ЕРО; ЈРО;	
			DERWENT	
-	13	, , , , , , , , , , , , , , , , , , ,	USPAT;	2004/02/27 11:11
		non-porous))) and rough\$4	US-PGPUB;	
			EPO; JPO; DERWENT	
-	9	((((laser same analyte) and ((surface substrate) with (("not" near porous)	USPAT;	2004/02/27 11:02
		non-porous))) and rough\$4) and (nanometer nm nano-rough\$4)	US-PGPUB;	200 02,27 11.02
Í			ЕРО; ЈРО;	
		20020107212 IDDN	DERWENT	2004/02/25 : 2 5
-	0	20020187312.URPN.	USPAT	2004/02/27 10:59
	13	(((laser same analyte) and ((surface substrate) with (("not" near porous) non-porous))) and rough\$4) and Laser	USPAT; US-PGPUB;	2004/02/27 11:07
		F	EPO; JPO;	
			DERWENT	
-	9	(((((laser same analyte) and ((surface substrate) with (("not" near	USPAT;	2004/02/27 11:12
	,	porous) non-porous))) and rough\$4) and (nanometer nm nano-rough\$4))	US-PGPUB;	
		and Laser	EPO; JPO;	
-	8507	((surface substrate) with (("not" near porous) non-porous))	DERWENT USPAT;	2004/02/27 11:11
		(and production product)	US-PGPUB;	
			ЕРО; ЛРО;	
L.			DERWENT	

-	98	(((surface substrate) with (("not" near porous) non-porous))) and (rough\$4 with (nanometer nm nano- nano))	USPAT; US-PGPUB;	2004/02/27 11:22
			EPO; JPO; DERWENT	
-	42	((((surface substrate) with (("not" near porous) non-porous))) and (rough\$4 with (nanometer nm nano- nano))) and Laser	USPAT; US-PGPUB;	2004/02/27 11:27
		(rought) with (nationictor intrinsico indico))) and Easter	ЕРО; ЛРО;	
_	. 15	((((((surface substrate) with (("not" near porous) non-porous))) and	DERWENT USPAT;	2004/02/27 11:18
		(rough\$4 with (nanometer nm nano- nano))) and Laser) and (adsor\$5 desor\$5 ioniz\$5 analyte)	US-PGPUB; EPO; JPO;	
-	3	((((((surface substrate) with (("not" near porous) non-porous))) and	DERWENT USPAT;	2004/02/27 11:21
		(rough\$4 with (nanometer nm nano- nano))) and Laser) and (laser with (desor\$5 ioniz\$5 analyte))	US-PGPUB; EPO; JPO;	
_	23253	(gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)	DERWENT USPAT;	2004/02/27 11:28
			US-PGPUB; EPO; JPO;	
_	241	((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)) and	DERWENT USPAT;	2004/02/27 11:25
		((surface substrate) with (("not" near porous) non-porous))	US-PGPUB; EPO; JPO;	
	130	(((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm))	DERWENT USPAT;	2004/02/27 11:29
	130	and ((surface substrate) with (("not" near porous) non-porous))) and	US-PGPUB;	2004/02/27 11.29
		laser	EPO; JPO; DERWENT	
-	0	(((((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)) and ((surface substrate) with (("not" near porous) non-porous))) and	USPAT; US-PGPUB;	2004/02/27 11:25
		laser) and (250/423R,424,425,423P.ccls.)	EPO; JPO; DERWENT	
-	3	((((gas\$4 analyte) with (rough\$4 nano-rough\$4 nano- nanometer nm)) and ((surface substrate) with (("not" near porous) non-porous))) and	USPAT; US-PGPUB;	2004/02/27 11:29
		laser) and (250/\$.ccls.)	EPO; JPO; DERWENT	
-	3	((((((surface substrate) with (("not" near porous) non-porous))) and (rough\$4 with (nanometer nm nano- nano))) and Laser) and analyte	USPAT; US-PGPUB;	2004/02/27 11:29
			EPO; JPO; DERWENT	
-	43545	metal with (rough\$4 nano-rough\$4 nano- nanometer nm)	USPAT; US-PGPUB;	2004/02/27 11:29
			EPO; JPO; DERWENT	
-	663	(metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and analyte	USPAT; US-PGPUB;	2004/02/27 11:29
			ЕРО; ЈРО;	
-	397	((metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and analyte)	DERWENT USPAT;	2004/02/27 11:29
		and laser	US-PGPUB; EPO; JPO;	
-	28	(((metal with (rough\$4 nano-rough\$4 nano- nanometer nm)) and	DERWENT USPAT;	2004/02/27 13:29
		analyte) and laser) and (250/\$.ccls.)	US-PGPUB; EPO; JPO;	
-	21287	metal with rough\$4	DERWENT USPAT;	2004/02/27 14:48
			US-PGPUB; EPO; JPO;	
			DERWENT	

- 890 (metal with rough\$4) and ((nanometer nano nm) same rough\$4) - 890 (metal with rough\$4) and (laser with (in situ)) - 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (SPAT; US-PGPUB; EPO, JPO, DERWENT USPAT; US-PGPUB; US-PGPU	27 13:53 27 13:39
- 890 (metal with rough\$4) and (laser with (in situ)) - 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ))) - 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4)) and ((met	27 13:39
- 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; US-PGPUB; EPO; JPO; DERWENT ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; US-PGPUB; EPO; JPO; DERWENT ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; US-PGPUB; EPO; JPO; DERWENT ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT USP-GPUB;	27 13:39
US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; J	27 13:39
- 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ))) - 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 23 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and (USPAT; US-PGPUB; EPO; JPO; DERWENT US	
- 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ))) - 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 (((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 (((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous))	
- 155 ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ))) - 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; US-PGPUB; EPO; JPO; DERWENT ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT US-P	
((metal with rough\$4) and (laser with (in situ))) 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and (USPAT; (US-PGPUB; EPO; JPO; DERWENT) 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) 198 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser 2004/02/2 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	
- 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT;	:7 14:48
- 27 (((metal with rough\$4) and ((nanometer nano nm) same rough\$4)) and ((metal with rough\$4) and (laser with (in situ)))) and analyte - 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT	7 14:48
((metal with rough\$4) and (laser with (in situ)))) and analyte US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT	7 14:48
- 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; - 2004/02/2	
- 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	
- 198 (rough\$4 nano-rough\$4) with (("not" near porous) non-porous) - 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT USPAT; USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; USPAT; 2004/02/2	
US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT USPAT; 2004/02/2	
- 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser	.7 14:02
- 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and laser 2004/02/2 - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2 - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	
- 22 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; US-PGPUB; EPO; JPO; DERWENT - 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	
laser US-PGPUB; EPO; JPO; DERWENT USPAT; 2004/02/2	7 13:55
EPO; JPO; DERWENT USPAT; 2004/02/2	
- 3 ((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	
analyte US-PGPUB;	7 13:53
1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	
EPO; JPO;	
DERWENT 2 (((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2	7 12.54
- 2 (((rough\$4 nano-rough\$4) with (("not" near porous) non-porous)) and USPAT; 2004/02/2 laser) and (((rough\$4 nano-rough\$4) with (("not" near porous) US-PGPUB;	,7 13:34
non-porous)) and analyte) Instrument In	
DERWENT	
- 21287 (rough\$4 nano-rough\$4) with (metal) USPAT; 2004/02/2	7 13:55
US-PGPUB;	
EPO, JPO,	
DERWENT	
- 2654 ((rough\$4 nano-rough\$4) with (metal)) and laser USPAT; USPAT; USPAT;	.7 14:03
US-PGPUB; EPO; JPO;	
DERWENT	
- 133 ((rough\$4 nano-rough\$4) with (metal)) and analyte USPAT; 2004/02/2	7 13:55
US-PGPUB;	
EPO; JPO;	
DERWENT	
- 109 (((rough\$4 nano-rough\$4) with (metal)) and laser) and (((rough\$4 USPAT; 2004/02/2	7 13:55
nano-rough\$4) with (metal)) and analyte) US-PGPUB;	
EPO; JPO; DERWENT	
- 10 ((((rough\$4 nano-rough\$4) with (metal)) and laser) and (((rough\$4 USPAT; 2004/02/2	7 14:01
nano-rough\$4) with (metal)) and analyte)) and 250/\$.ccls. US-PGPUB;	.7 14.01
EPO; JPO;	
DERWENT	
- 14 (mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with USPAT; 2004/02/2	
(("not" near porous) non-porous metal)) US-PGPUB;	7 14:13
EPO; JPO;	7 14:13
DERWENT USPAT; 2004/02/2	7 14:13
- 10 ((mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with USPAT; 2004/02/2 ("not" near porous) non-porous metal))) and laser US-PGPUB;	
((not near perous) non-perous mean())) and laser (OS-1 OI OB, EPO, JPO;	7 14:13
DERWENT	

	10	(((mass near spectromet\$2) same ((rough\$4 nano-rough\$4 nano) with	USPAT;	2004/02/27 14:46
•	10	((mass near spectromets2) same ((roughs4 nano-roughs4 nano) with (("not" near porous) non-porous metal))) and laser) and ((nanometer	US-PGPUB;	2004/02/27 14:46
		nano nm))	EPO; JPO;	
			DERWENT	
i	8200	((nanometer nano nm) with rough\$4)	USPAT;	2004/02/27 14:49
_	3200	((Indionicter fiddo fift) with foughts-)	US-PGPUB;	2004/02/27 14.47
	-		EPO; JPO;	
			DERWENT	
	2712	(((nanometer nano nm) with rough\$4)) and laser	USPAT;	2004/02/27 14:53
	2/12	(((nationieter natio init) with fought 4)) and laser	US-PGPUB;	2004/02/27 14.55
			EPO; JPO;	
			DERWENT	
_	221	(((nanometer nano nm) with rough\$4)) and analyte	USPAT;	2004/02/27 14:13
-	221	(((nanometer nano min) with roughts-1)) and analyte	US-PGPUB;	2004/02/27 14.13
			EPO; JPO;	
			DERWENT	
	137	((((nanometer nano nm) with rough\$4)) and laser) and ((((nanometer	USPAT;	2004/02/27 14:13
-	137	nano nm) with rough\$4)) and analyte)	US-PGPUB;	2004/02/27 14.13
		land min) with roughts 4)) and analyte)		
			EPO; JPO; DERWENT	
	23	(((((nanometer nano nm) with rough \$4)) and losse) and ((((nanometer	1	2004/02/27 14:13
-	23	((((((nanometer nano nm) with rough\$4)) and laser) and ((((nanometer	USPAT; US-PGPUB;	2004/02/27 14:13
		nano nm) with rough\$4)) and analyte)) and ((mass near spectromet\$2) (ion adj mobility))	1	
		(lon adj modinty))	EPO; JPO; DERWENT	
	16	(motel with rough\$4) same loser same analyte	USPAT;	2004/02/27 14:49
•	10	(metal with rough\$4) same laser same analyte		2004/02/27 14:49
			US-PGPUB;	
			EPO; JPO; DERWENT	
	15	((metal with rough\$4) same laser same analyte) and (nanometer nano	USPAT;	2004/02/27 14:52
-	13		US-PGPUB;	2004/02/27 14.32
		nm nano-)	EPO; JPO;	
			DERWENT	
	0	nano-rough\$4 with analyte	USPAT;	2004/02/27 14:52
-	1	liano-roughto4 with analyte	US-PGPUB;	2004/02/27 14.32
			EPO; JPO;	
			DERWENT	
_	150	rough\$4 with analyte	USPAT;	2004/02/27 14:53
-	150	Tought with many to	US-PGPUB;	2004/02/27 14.55
	1		EPO; JPO;	
			DERWENT	
_	77	(rough\$4 with analyte) and laser	USPAT;	2004/02/27 14:53
	''	(Tought With analyte) and fuser	US-PGPUB;	200 1/02/27 11:55
			EPO; JPO;	
			DERWENT	
_	57	((rough\$4 with analyte) and laser) and (nanometer nano nano- nm)	USPAT;	2004/02/27 15:03
	,	(1006110 1 William and 1001) and (maiorine in maiorine)	US-PGPUB;	200 1/02/27 15:05
			EPO; JPO;	
,			DERWENT	
_	5	((improv\$4 increas\$4) near3 analyte) with (rough\$4)	USPAT;	2004/02/27 16:41
		((improve increase) reads analyte) with (roughle)	US-PGPUB;	2001/02/27 10:41
			EPO; JPO;	
i	i		DERWENT	
_	0	20020187312.URPN.	USPAT	2004/02/27 15:52
	39	Fonash-Stephen\$.in.	USPAT;	2004/02/27 15:53
		1 ones orapione.in.	US-PGPUB;	2007102121 13.33
			EPO; JPO;	
			DERWENT	
_	6	Fonash-Stephen\$.in. and (rough\$4)	USPAT;	2004/02/27 15:53
•		1 onesi otopionomin and (100gmpt)	US-PGPUB;	200-102/2/ 15.55
			ЕРО; ЛРО;	
			DERWENT	
	1		,	1

	r			
-	93	((improv\$4 increas\$4) near3 ion) with (rough\$4)	USPAT; US-PGPUB;	2004/02/27 15:55
1			ЕРО; ЈРО;	
:			DERWENT	
-	26	(((improv\$4 increas\$4) near3 ion) with (rough\$4)) and laser	USPAT;	2004/02/27 16:23
			US-PGPUB; EPO; JPO;	
			DERWENT	
_	359	((mass adj spectromet\$2) (ion adj mobility)) same rough\$4	USPAT;	2004/02/27 16:24
		(US-PGPUB;	
			ЕРО, ЈРО,	
			DERWENT	
-	135	(((mass adj spectromet\$2) (ion adj mobility)) same rough\$4) and laser	USPAT;	2004/02/27 16:03
			US-PGPUB;	
			EPO; JPO; DERWENT	
<u> </u>	54	((((mass adj spectromet\$2) (ion adj mobility)) same rough\$4) and laser)	USPAT;	2004/02/27 16:23
	٠.	and analyte	US-PGPUB;	2001102727 10:25
			ЕРО; ЛРО;	
			DERWENT	
-	3406	(ion analyte) with (rough\$4)	USPAT;	2004/02/27 16:23
			US-PGPUB;	
			EPO; JPO; DERWENT	
-	705	((ion analyte) with (rough\$4)) and laser	USPAT;	2004/02/27 16:42
		((constant) to) man (congate t)) man tares	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	281	((ion analyte) with (rough\$4)) and ((mass adj spectromet\$2) (ion adj	USPAT;	2004/02/27 16:24
		mobility))	US-PGPUB; EPO; JPO;	
			DERWENT	
-	97	(((ion analyte) with (rough\$4)) and laser) and (((ion analyte) with	USPAT;	2004/02/27 16:24
		(rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))	US-PGPUB;	
			ЕРО; ЈРО;	
	59	(((ion analyta) with (novah (A)) and losses) and (((ion analyta) with	DERWENT	2004/02/27 16:25
-	39	((((ion analyte) with (rough\$4)) and laser) and (((ion analyte) with (rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))) and	USPAT; US-PGPUB;	2004/02/27 10:23
		(nanometer nm)	ЕРО; ЛРО;	
		,	DERWENT	
-	51		USPAT;	2004/02/27 16:32
		(rough\$4)) and ((mass adj spectromet\$2) (ion adj mobility)))) and	US-PGPUB;	
		(nanometer nm)) and (silicon carbon polymer graphite)	EPO; JPO; DERWENT	
_	1	((enhanc\$4) near3 analyte) with (rough\$4)	USPAT;	2004/02/27 16:40
	•	((Chimino)) None unity to) Wal (Nought !)	US-PGPUB;	200 11 02/27 10:10
		·	ЕРО; ЈРО;	
			DERWENT	
-	6	((enhanc\$4) near3 ion) with (rough\$4)	USPAT;	2004/02/27 16:41
			US-PGPUB; EPO, JPO;	
			DERWENT	
_	32	((analyte) with (rough\$4)) same (nanometer nm nano nano-)	USPAT;	2004/02/27 16:42
			US-PGPUB;	
			ЕРО, ЈРО;	
	26	(((analyte) with (rough\$4)) same (nanometer nm nano nano-)) and laser	DERWENT	2004/02/27 16:42
	20	(((analyse) with (lought-1) same (nanometer thin hano hano-)) and laser	USPAT; US-PGPUB;	2004/02/27 16:43
			ЕРО; ЛРО;	
			DERWENT	

-	3	((absorb with analyte) same rough\$4)	USPAT;	2004/02/27 16:49
			US-PGPUB;	
		·	ЕРО; ЈРО;	
	÷		DERWENT	